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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Eun-sung LEE, et al.

Art Unit: 2811

Serial No. 10/773,312

Examiner: Hung K. Vu

Filed: February 9, 2004

Confirmation No. 6650

For: MEMS DEVICE AND FABRICATION
METHOD THEREOF

Attorney Docket No. 277/008 DIV

AMENDMENT UNDER 37 C.F.R. § 1.111

Mail Stop: Amendment
Commissioner for Patents
United States Patent and Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Office action mailed November 14, 2007, the following amendments and remarks are respectfully submitted in connection with the above-identified application:

Amendments to the Claims are reflected in a listing of claims, which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.